

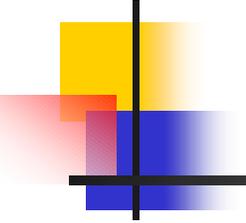
# Development of Conduction, Convection, Spreading and Contact Resistance Models for Microelectronics Applications

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# Outline

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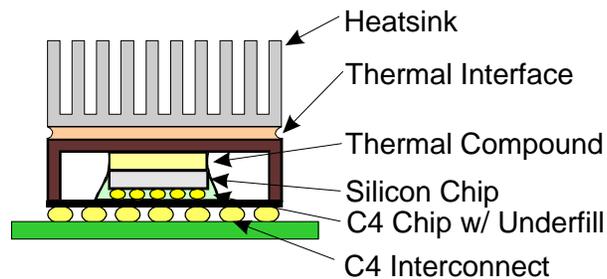


- Project Overview
- Objectives
- Year 1 Deliverables
- Design & Analysis Tools
- Personnel
- What Lies Ahead
- Concluding Comments

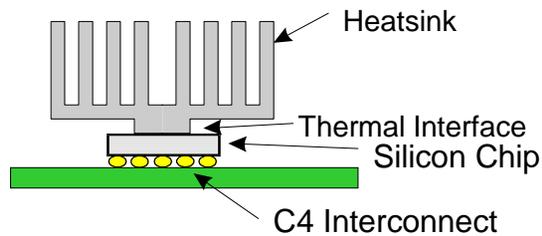
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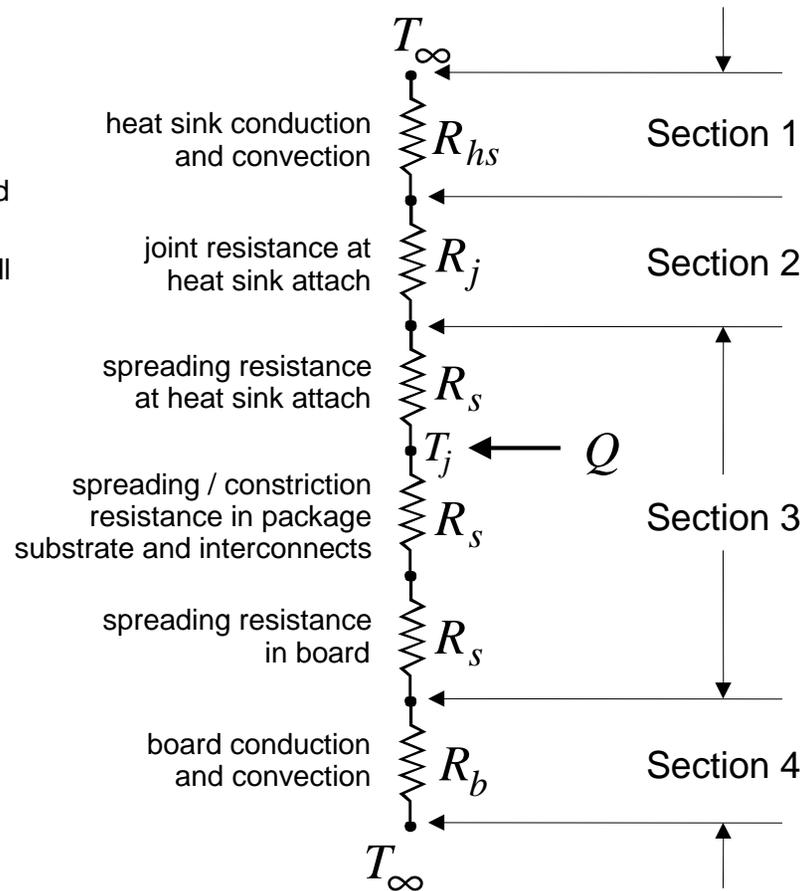
# Project Strategy



BGA with Heatsink

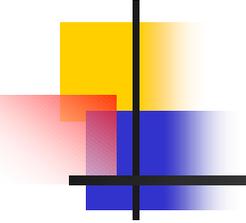


Flip Chip with Heatsink



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# Objectives

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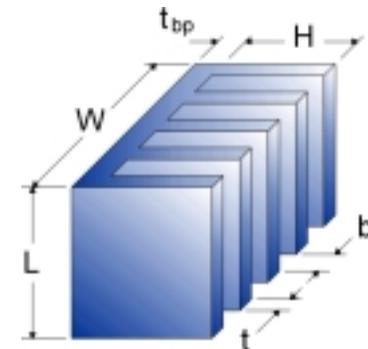


- Thermal model development:  
chip level → cooling medium
  - ✓ heat sink optimization
  - ✓ modeling & characterization of thermal interfaces
  - ✓ modeling of spreading & constriction resistance
  - ✓ modeling of conduction & convection in PWBs

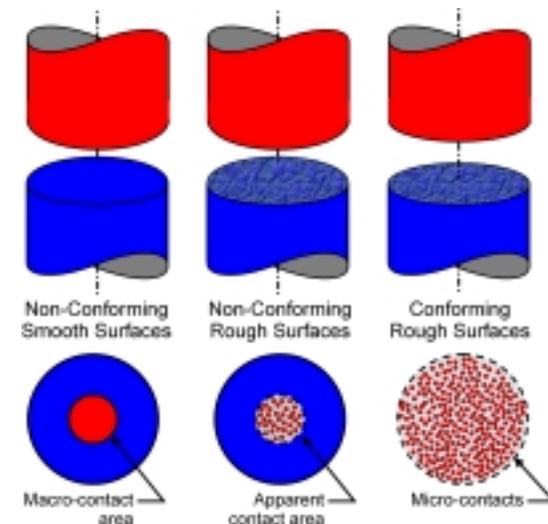
# Year 1 Deliverables



- Heat sink optimization model
  - ✓ shrouded, air-cooled, plate fin heat sink
  - ✓ interactive web-based modeling tool



- Thermal resistance models
  - ✓ non-conforming, smooth surfaces
  - ✓ conforming rough surfaces
  - ✓ Excel spreadsheet models



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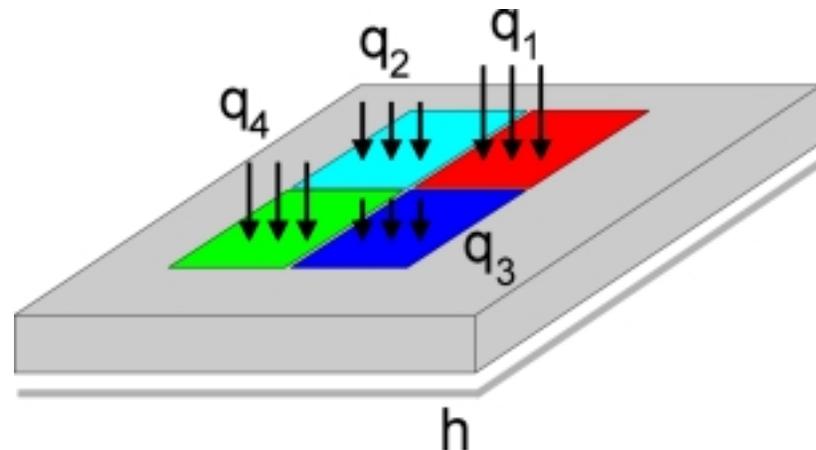
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# Year 1 Deliverables



## ■ Spreading resistance model for

- ✓ multiple discrete sources
- ✓ isotropic or multi-layered substrate
- ✓ interactive web-based modeling tool



## ■ Thermal Interface Test Rig

- ✓ design, build and commission test apparatus

# Heat Sink Optimization



Analysis Tool

vs.

Design Tool

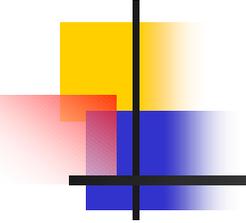
- design is known a priori
- used to calculate the performance of a given design, i.e.  $Nu$  or  $R$  vs.  $Re$
- cannot guarantee an optimized design

- used to obtain an optimized design for a set of known constraints i.e.

given:

- ✓ maximum temperature
- ✓ heat input
- ✓ maximum outside dimensions

find: the most efficient design



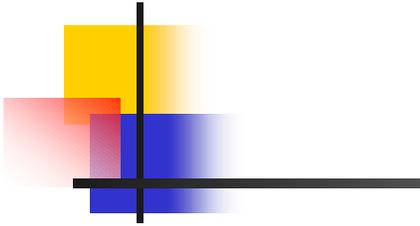
# Optimization Using EGM

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## Why use Entropy Generation Minimization?

- entropy production  $\propto$  amount of energy degraded to a form unavailable for work
- lost work is an additional amount of heat that could have been extracted
- degradation process is a function of thermodynamic irreversibilities e.g. friction, heat transfer etc.
- minimizing the production of entropy, provides a simultaneous optimization of all design variables



Heat Sink Optimization: Plate Fin - Microsoft Internet Explorer

File Edit View Favorites Tools Help

Back Forward Stop Refresh Home Search Favorites Media

## Heat Sink Optimization: Plate Fin

Instructions Background Input/Output References

**Optimize Value**

**Base Plate**

Length  100 mm

Width  100 mm

Thickness  10 mm

**Fin**

Height  50 mm

Thickness  2 mm

Number

**Thermal Conductivity**

Fin  180 W/mK

Baseplate  180 W/mK

Approach Velocity  2 m/s

**Maximum Dimensions**

L	W	H
100 mm	100 mm	50 mm

Calculate Reset

Typical Run times

Variables	1	2	3	4
Time (min)	1	3	10	30

**Value:** provide specific values for constrained parameters

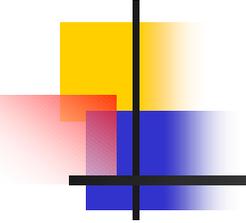
**Optimize:** indicate parameters to be optimized

**Calculate:** run optimization code to calculate design parameters for maximum thermal-fluid performance

Web URL: <http://mhtlab.uwaterloo.ca/onlinetools/optimize/index.html>

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# Contact Resistance Models

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- **Non-conforming, smooth surfaces:**
  - ✓ assume material waviness (out-of-flatness) predominates
  - ✓ microscopic roughness is negligible
  - ✓ example: heat sink on a silicon chip
  - ✓ determine contact, gap and joint resistance
  
- **Conforming rough surfaces:**
  - ✓ assume microscopic roughness predominates
  - ✓ out-of-flatness is negligible
  - ✓ example: two machined (lapped or ground) surfaces
  - ✓ determine contact, gap and joint resistance

# Non-Conforming Smooth Surfaces



**Contact Resistance for Non-Conforming Smooth Surfaces**

**Chip and Heat Sink Geometry**

	Chip	Heat Sink
Width (mm)	15	6
Length (mm)	15	6
Out of flatness (mm)	0.00762	0.00762
Thickness (mm)	0.75	0.5

**Gap**

Material: Air  
 P(atm): 1  
 T (°C): 50  
 k(W/m.K): 0.028  
 Beta [-]: 1.643  
 Alpha [-]: 2.44  
 Lambda (Micro m): 0.064

**Chip and Heat Sink Material**

	Chip	Heat Sink
Material	Silicon	Al 6063T5
k (W/m.K)	125	209
E (GPa)	163	70
Poisson ratio	0.30	0.30

**Results**

	Resistance (K/W)
Chip	
Heat Sink	
Gap	
Total	

Decimals: 3

**Condition**

h (W/(m<sup>2</sup>.K)): 500  
 Contact Load (N): 7.41

**Equations:**

$$R = \frac{\bar{T}_s - T_f}{Q}$$

$$h = \frac{Q_{\text{heat sink}}}{A_{\text{interface}} \Delta T_{\text{heat sink}}}$$

**Buttons:** Calculate, Exit, Help

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# Conforming Rough Surfaces



**Contact Resistance for Conforming Rough Surfaces**

Surfaces Geometry		
	Width (mm)	Length (mm)
Surface 1	15	15
Surface 2	6	6

Surface Information			
Material	Conductivity (W/m.K)	Roughness ( $m \times 10^{-6}$ )	Microhardness (MPa)
Al 6063 (Flycut)	201	0.4	1094
Alumina (96% Al <sub>2</sub> O <sub>3</sub> )(Ground)	20.9	1.3	3100

**Contact Pressure**

Contact Pressure (MPa)

**Gap Information**

Material	Temp. (°C)	Pressure (atm.)	Conductivity (W/m.K)	Gap Parameter $M0 \times 10^6$ , (m)
Air	50	1	0.028	0.373

**Thermal Resistance (K/W)**

Contact Resistance  Decimal

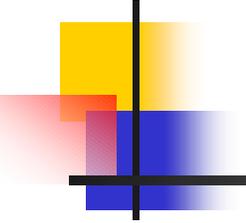
Gap Resistance

Joint Resistance

**Calculate**  
**Exit**  
**Help**

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# Spreading Resistance Model

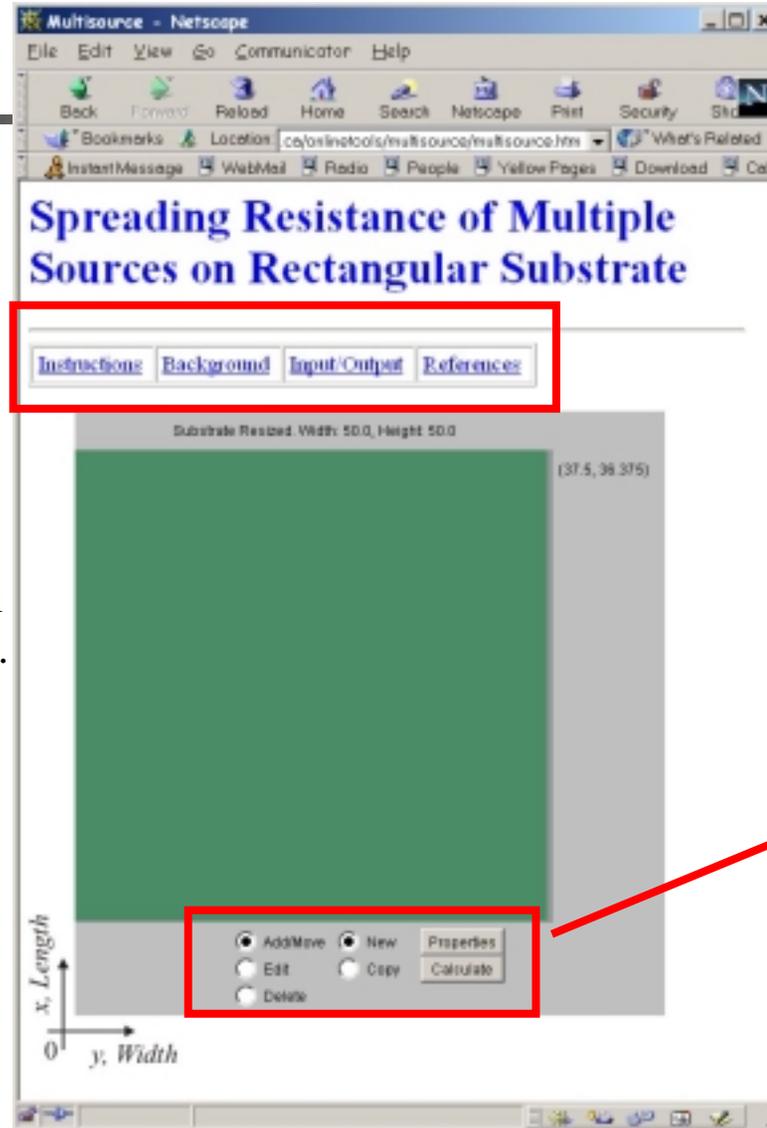
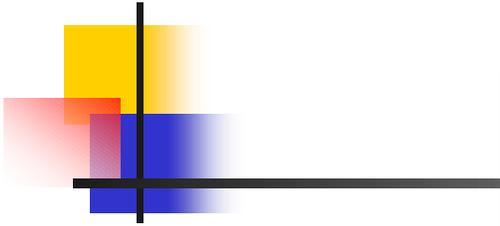
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- Analytical solution for heat sources on a rectangular flux channel
  - ✓ isotropic or laminated substrates
  - ✓ multiple discrete sources

- Model details in:

“Muzychka, Y.S., Culham, J.R. and Yovanovich, M.M., 2000, *“Thermal Spreading Resistance of Eccentric Heat Sources on Rectangular Flux Channels,”* ASME IMECE, Orlando, FL, November 5-10.



**Instructions:** user's guide & sample problem

**Background:** governing eqns. & model development

**Input/Output:** data entry & units

**References:** publications & sample pdf files

**Properties:** set substrate & source properties

**Add/move, Edit, Delete,**

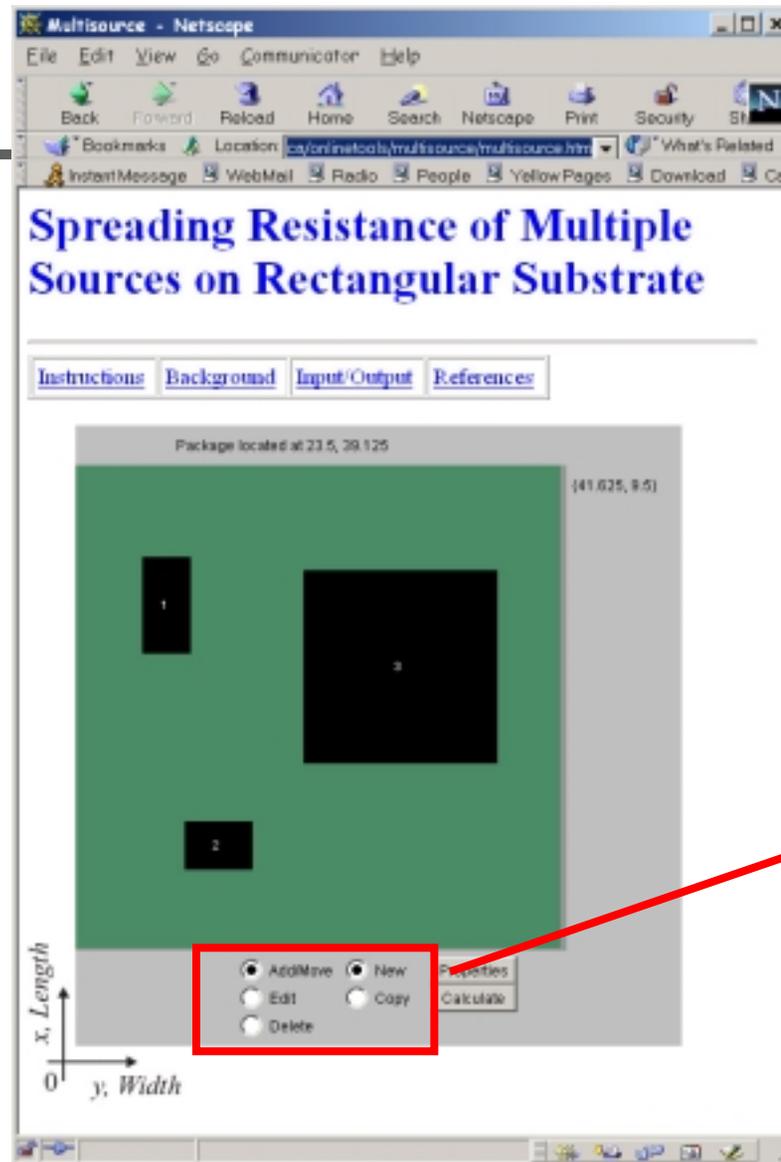
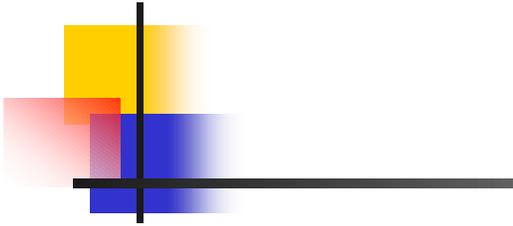
**New, Copy:** on screen package placement

**Note:** Java source requires Netscape (IE will not work)

**Web URL:** <http://mhtlab.uwaterloo.ca/onlinetools/multisource/index.html>

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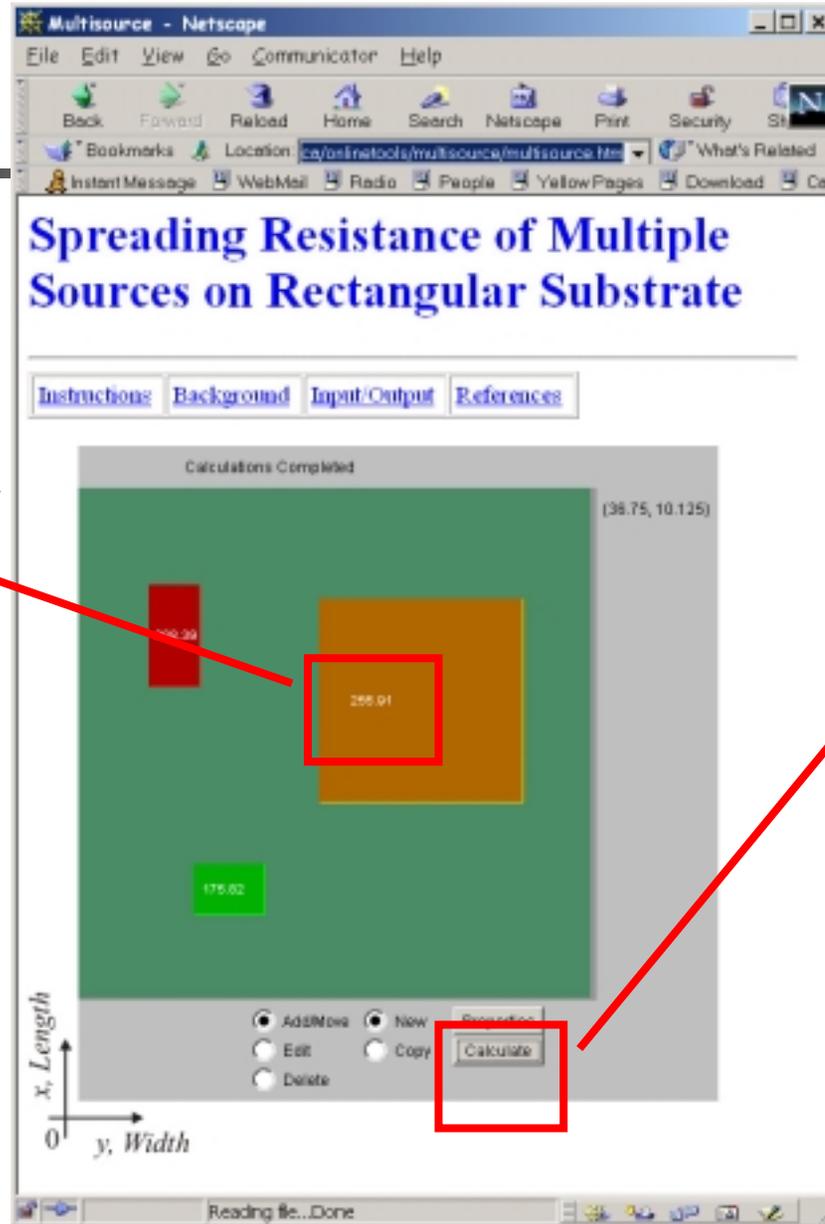
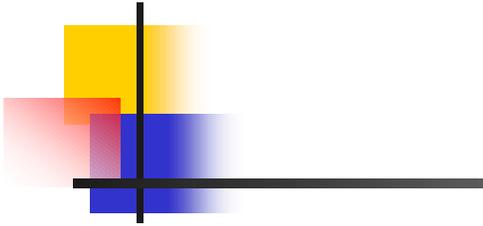
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Add a new source: a pop-up window will appear for entering heat source inputs  
- click on substrate to place current heat source

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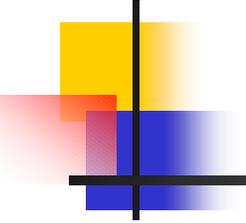
Mean source temperature rise -  $^{\circ}\text{C}$

**Calculate:** click calculate to obtain mean heat source temperature rise for each source

- Java-based code will be executed on local CPU
- typical run times are approximately 10 seconds per source

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# Thermal Interface Materials

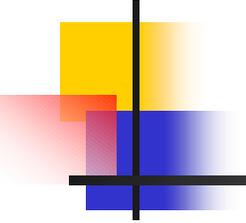
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- Design, build & commission test apparatus & data acquisition interface for testing interface materials:
  - ✓ Measure joint resistance and thermal conductivity as function of:
    - interface temperature
    - contact pressure
    - material properties
    - surface characteristics
  - ✓ in-situ thickness measurement: sub micron precision

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# Testing Capabilities

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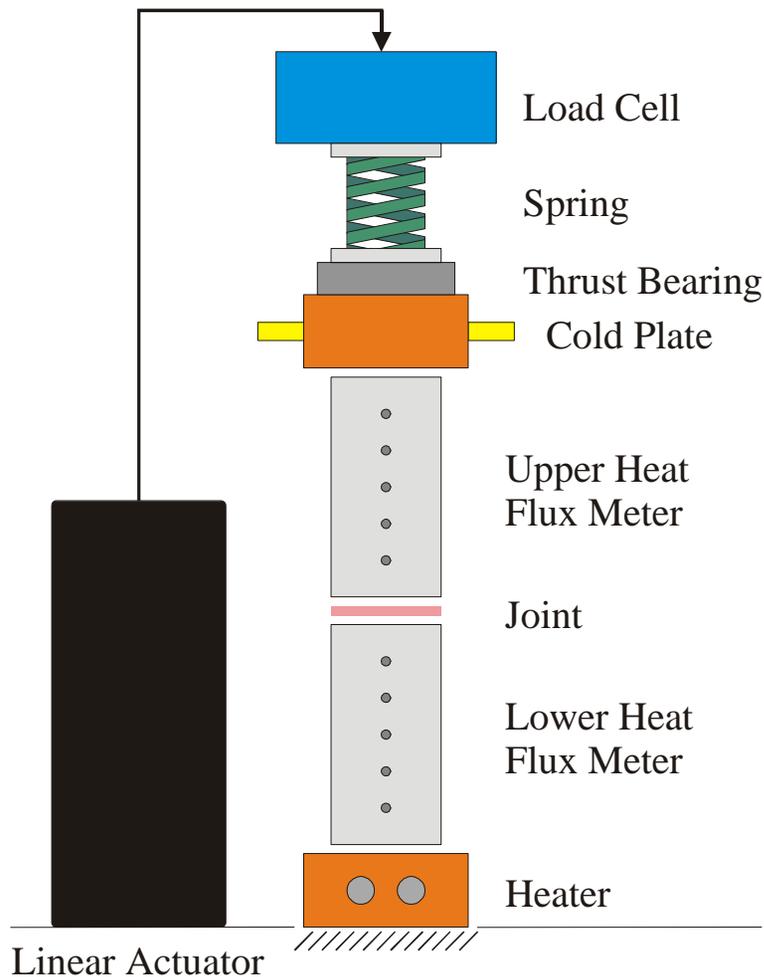


- 4 categories of materials can be tested
  - ✓ materials requiring stops & minimal clamping force
    - grease, liquids, phase change
  - ✓ materials deforming more than 10% under clamping force - compliant materials
  - ✓ materials deforming less than 10%, no stops required - hard rubber
  - ✓ thermally conductive materials requiring high clamping force - ceramics & plastics

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# Apparatus

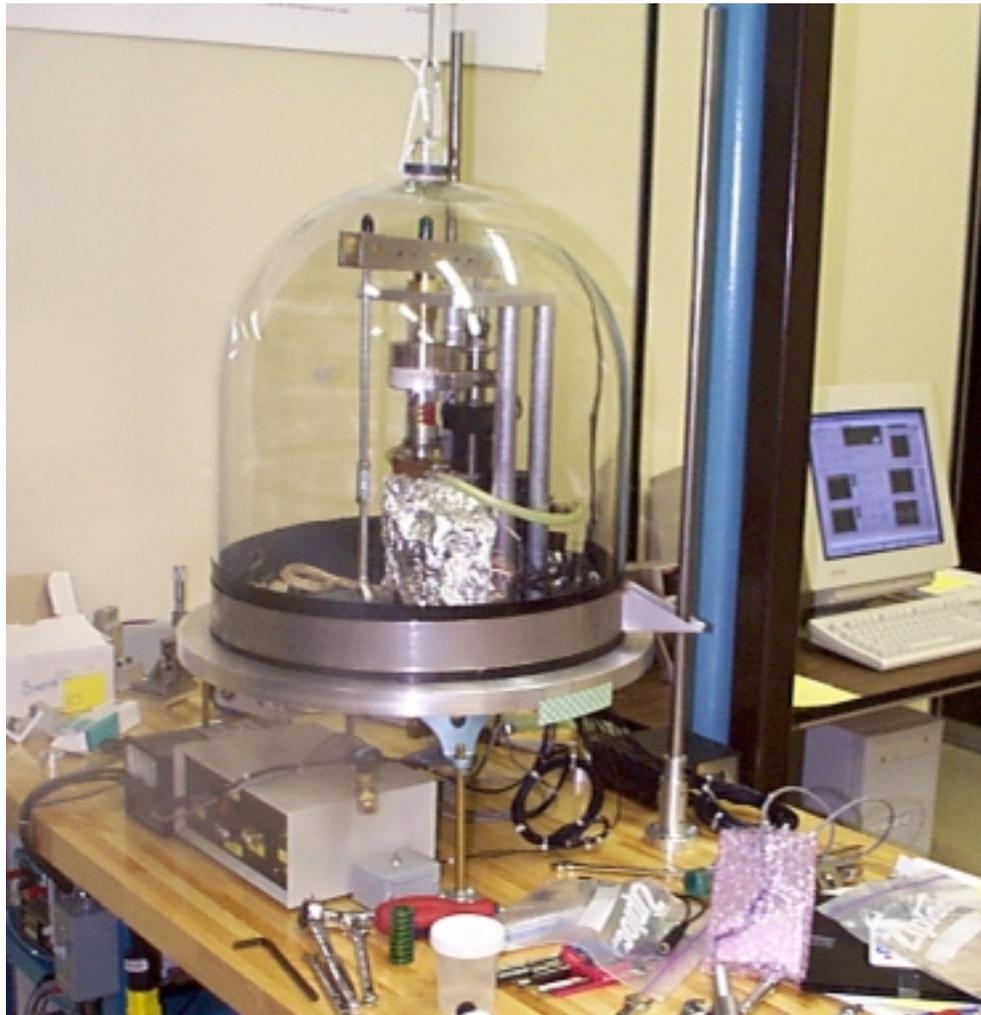


- Load cell
  - ✓ 100 or 1000 lbs
- Spring to compensate for thermal expansion
- Thrust bearing to remove torque loads
- Linear actuator
  - ✓ digitally controlled stepper motor
  - ✓ 400 steps / rev
  - ✓ 0.1 inch per revolution

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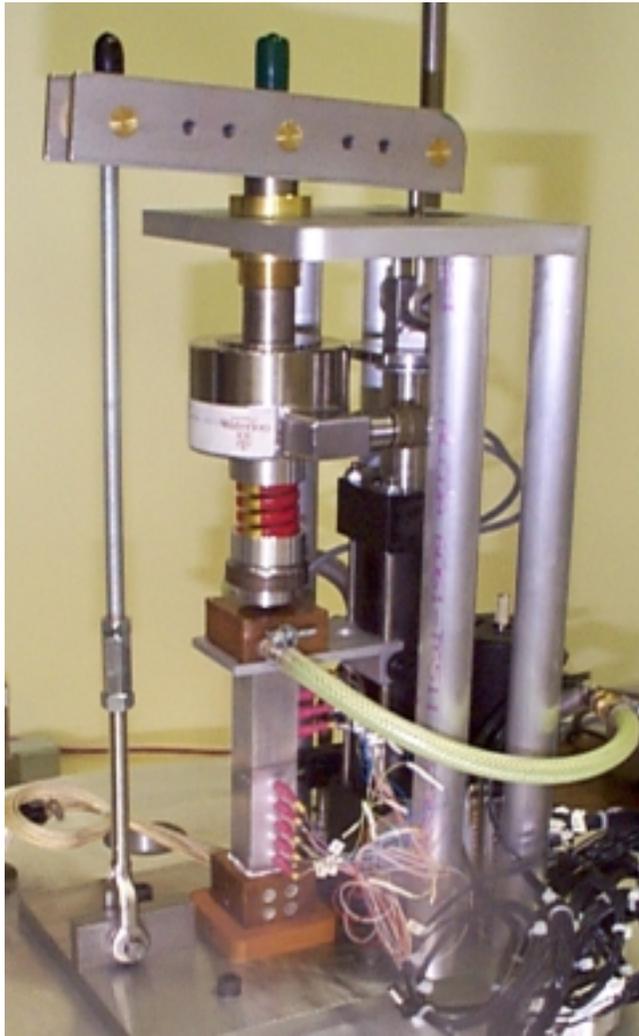
# Thermal Interface Test Apparatus



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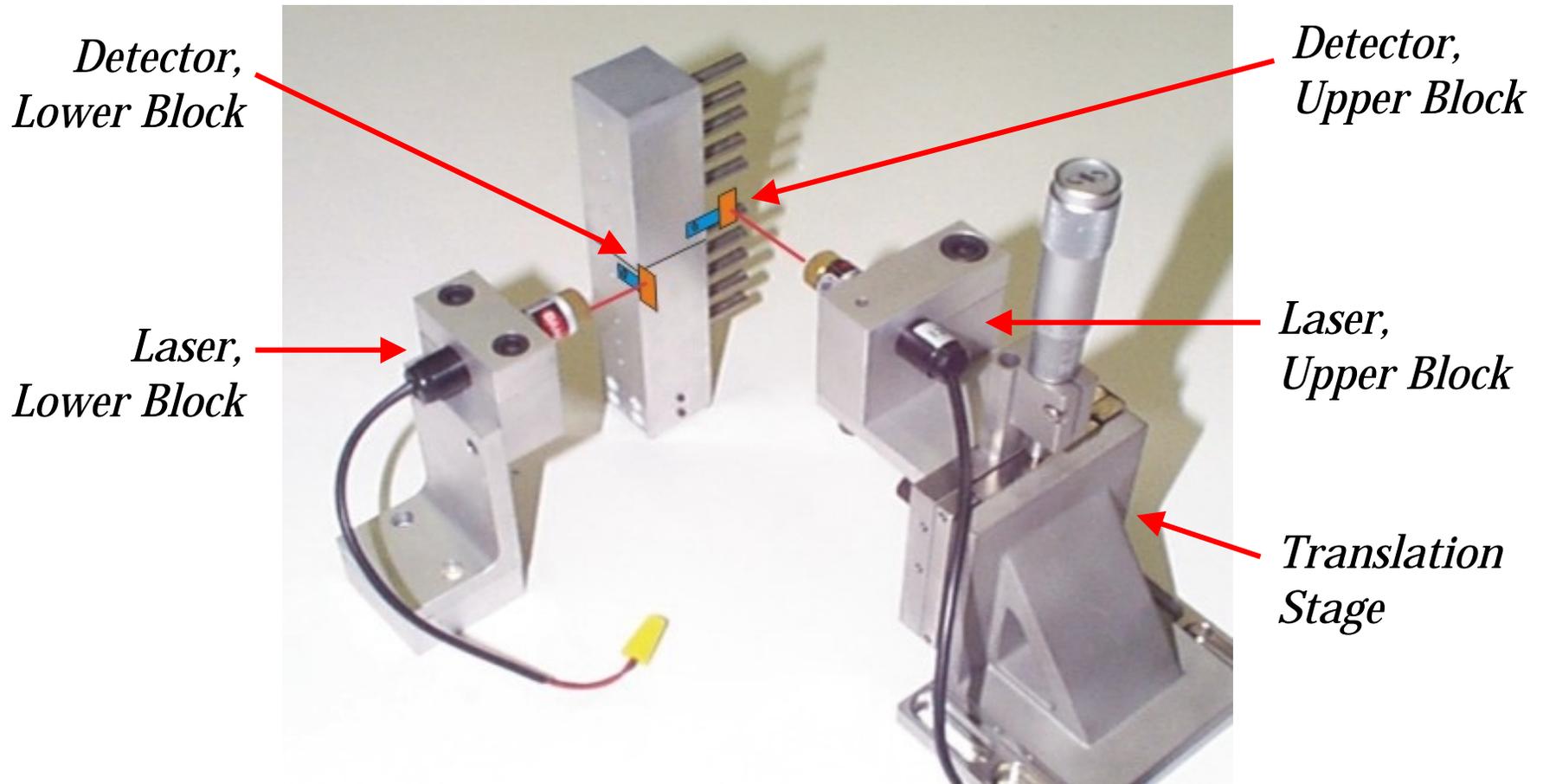
# Thermal Interface Test Apparatus



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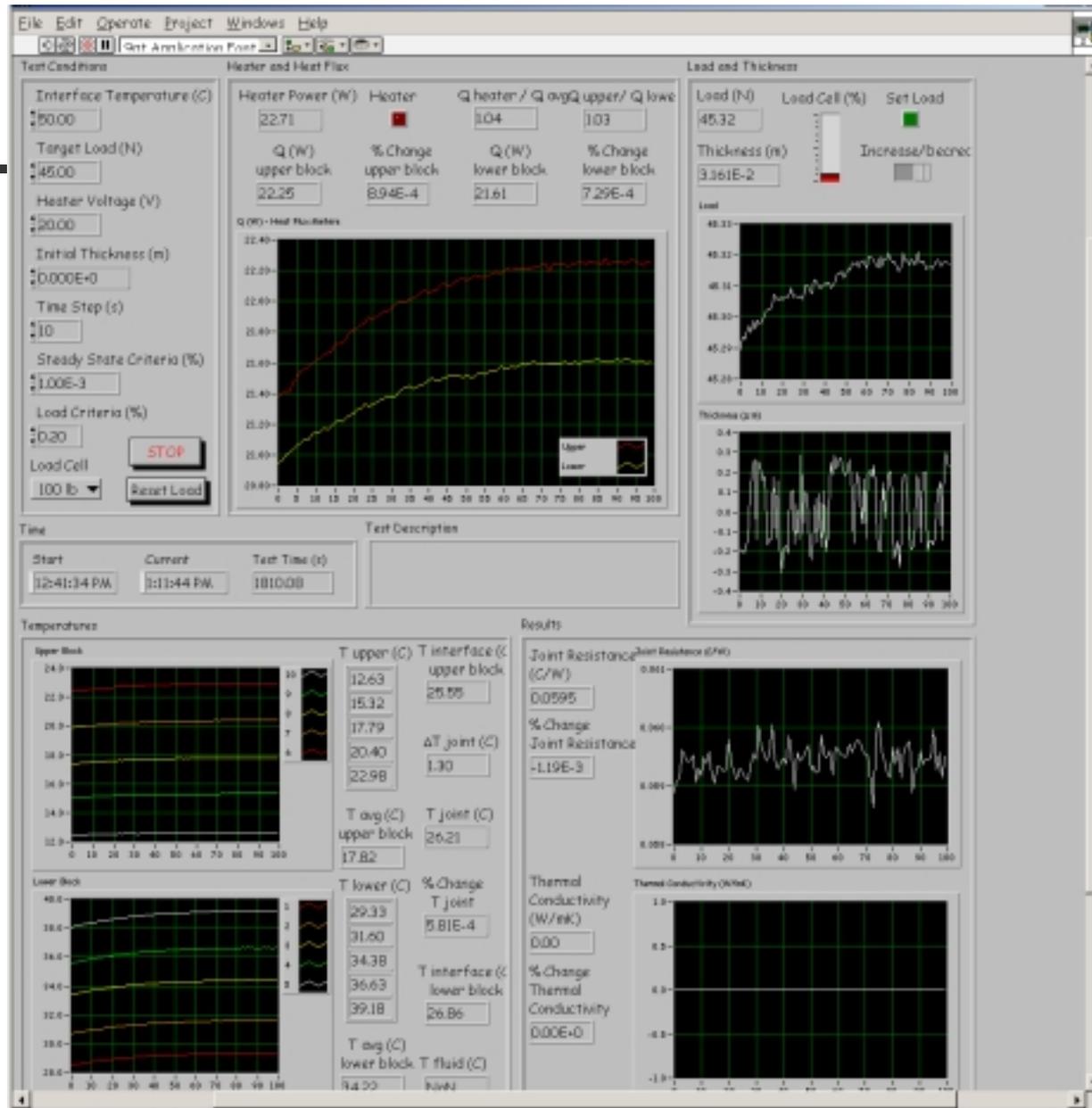
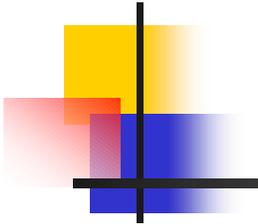
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# Thickness and Deflection



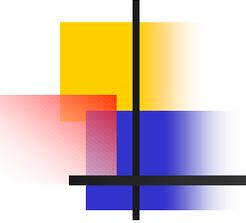
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# HQP's

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- Graduate Students

- ✓ Mr. Majid Bahrami

- Ph.D candidate - *topic*: contact resistance in non-conforming rough surfaces

- ✓ Ms. Irena Savija

- M.A.Sc. Candidate - *topic*: modeling and characterization of thermal interface materials

- Summer Students

- ✓ Mr. Joel Reardon and Mr. Chris Hurley

- Web tool model development: Java, C, Javascript, CGI

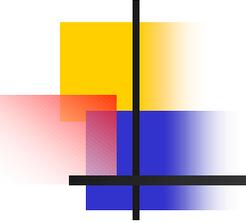
- Senior Undergraduate Projects

- ✓ Dana Frigula and Matthew Morrissey

- Laser measurement system

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# What Lies Ahead

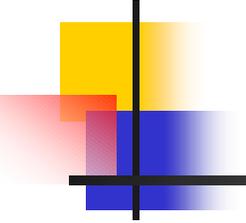
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- Heat sink models for base plate enhancements such as copper inserts, laminates and heat pipes
- Heat sink flow by-pass models
- Joint resistance models for non-conforming rough surfaces
- Thermal interface models: grease, phase change materials and compliant polymers
- Board level modeling

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# Concluding Comments

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- Thank you to sponsoring companies:
  - ✓ Alcatel
  - ✓ Celestica
  - ✓ Dy4
  - ✓ Coretec
- Cross our fingers for a successful CFI bid in the new year

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